EEBM6381 - Advanced Concepts in Microscopy

EEBM 6381 (BMEN 6381) Advanced Concepts in Microscopy (3 semester hours) Continuation of EEBM 6380, with emphasis on advanced approaches such as vectorial diffraction, stochastic aspects of image formation and analysis. Prerequisites: EEBM 6380 or BMEN 6380 or by instructor permission. (3-0) Y